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SHEET 1 OF 2

INFORMATION DISCLOSURE CITATION			Atty Docket 65321 / 269250	Serial No. Not Yet Assigned 09/941 360	U.S. PRO 11017 U.S. PRO 1009/941 360 08/28/01	
PTO-1449			Applicant: Farhat et al.			
Date Mailed: August 28, 2001			Filing Date August 28, 2001		Group Art Unit 1741	
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>DRV</i>	3959089	05/25/76	Watts			
<i>DRV</i>	4610772	09/09/86	Palnik			
<i>DRV</i>	5024735	06/18/91	Kadija			
<i>DRV</i>	6004880	12/21/99	Liu et al			
<i>DRV</i>	3395092	07/30/68	Ribes			
<i>DRV</i>	3436259	04/01/69	Regh et al.			
<i>DRV</i>	3890746	06/24/75	Saegusa et al.			
<i>DRV</i>	5863412	01/26/99	Ichinoise et al.			
<i>DRV</i>	5755859	05/26/98	Brusic et al.			
<i>DRV</i>	5807165	09/15/98	Uzoh et al.			
<i>DRV</i>	5930669	07/27/99	Uzoh			
<i>DRV</i>	5933753	08/03/99	Simon et al.			
<i>DRV</i>	6004880	12/21/99	Liu et al.			
<i>DRV</i>	5171412	12/15/92	Talieh et al.			
<i>DRV</i>	5429733	07/04/95	Ishida			
<i>DRV</i>	5558568	09/24/96	Talieh et al.			
<i>DRV</i>	5650039	07/22/97	Talieh			
<i>DRV</i>	5692947	12-02-97	Talieh et al.			
<i>DRV</i>	5833820	11/10/98	Dubin			
EXAMINER <i>Donald R Valentine</i>			DATE CONSIDERED 6/03			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
<i>DRV</i>	DE 2008664	09/09/71	Germany				
<i>DRV</i>	DE 4324330	03/02/94	Germany				
<i>DRV</i>	EP 0903774 A2	03/24/99	EP				
<i>DRV</i>	EP 0960693 A2	12/01/99	EP				
<i>DRV</i>	WO 95/00295	01/05/95	PCT				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>DRV</i>	M. Rubinstein, "Tampongalvanisieren in de Praxis, Teil 2." GALVANOTECHNIK, Vol. 79, No. 10, 1988, pp. 3263-3270						<i>No Month</i>
<i>DRV</i>	J.M. Steigerwald, R. Zirpoli, S.P. Murarka, D. Price and R.J. Gutman, "Pattern Geometry Effects in the Chemical-Mechanical Polishing of Inlaid Copper Structures", October 1994, pp. 2842-2848						
<i>DRV</i>	Alan C. West, Chin-Chang Cheng and Brett C. Baker, "Pulse Reverse Copper Electrodeposition in High Aspect Ratio Trenches and Vias", September 1998, pp. 070-3073						
<i>DRV</i>	Robert C. Contolini, Anthony F. Bernhardt and Steven Mayer, "Electrochemical Planarization for Multilevel Metallization", September 1994, pp. 2503-2510						
<i>DRV</i>	C. Madore, M. Matlosz and D. Landolt, "Blocking Inhibitors in Cathodic Leveling", I. Theoretical Analysis", December 1996, pp. 3927-3942						
EXAMINER <i>Donald R Valentin</i>	DATE CONSIDERED <i>6/03</i>						

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